

**OPEN UNIVERSITY OF TANZANIA**  
**FACULTY OF SCIENCE, TECHNOLOGY AND ENVIRONMENTAL STUDIES**

**OPH 443: MICROELECTRONICS**

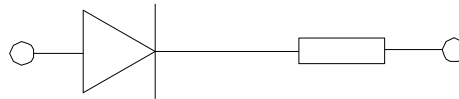
**INSTRUCTIONS:**

- Write your **full name**, postal address and **registration number**
- Remember to submit Assignment 1 before **12<sup>th</sup> December 2008** and Assignment 2 before **27<sup>th</sup> March 2009**.

**ASSIGNMENT I – 2009**

**Caution: Define all symbols used.**

1. (a) What is dry etching?
- (b) The following circuit is to be integrated.



Assuming an n-substrate base, draw a cross-section of the IC for the monolithic diode.

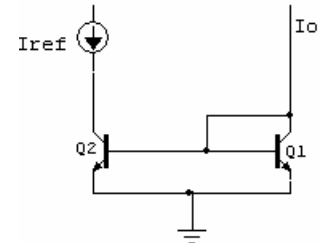
2. It is required to design an integrated resistor starting with a p-substrate.
  - (a) Sketch a well labeled cross section structure.
  - (b) What are the parameters to be considered in defining the magnitude of the resistor?
3. (a) What is sheet resistance?
- (b) A base diffused integrated resistor with sheet resistance of  $200\Omega/\square$  has the dimensions of  $25\mu\text{m}$  wide and  $250\mu\text{m}$  long. Assuming no empirical corrections, what is the resistance represented.
4. It is required to design a MOS capacitor starting with a p-substrate.
  - (a) Sketch the cross section structure.
  - (c) A thin film capacitor has a capacitance of  $0.5\text{ pF}/(\mu\text{m})^2$ . The thickness of silicon dioxide is  $800\text{ Angstrom}$ . Calculate the relative dielectric constant of the  $\text{SiO}_2$  layer.
5. A bar of N type silicon,  $2\text{ cm}$  long, cross sectional area  $1\text{ cm}^2$  and donor concentration  $10^{15}\text{ cm}^{-3}$  has ohmic contacts at the ends. If the resistance is  $10\ \Omega$ , find the electron mobility.
6. Given the carrier mobility  $\mu = 2000\text{ cm}^2\text{V}^{-1}\text{s}^{-1}$  at  $0^\circ\text{C}$ , calculate the carrier diffusion constant at the same temperature.
7. (a) Excess carriers are injected on one surface of a thin slice of N-Type Si with length  $W$  and are extracted at the opposite surface where  $p_n(W) = p_{n0}$ . There is no electric field in the region  $0 < x < W$ . Derive the expression for the current densities at the two surfaces.
- (b) If the carrier lifetime is  $50\ \mu\text{s}$  and  $W = 0.1\text{ mm}$ , calculate the portion of the injected current which reaches the opposite surface by diffusion, given the diffusion constant  $D = 50\text{ cm}^2\text{s}^{-1}$ .

8. A rectangular block of homogeneously doped N<sup>-</sup>-type Si,  $N_D = 10^{15} \text{ cm}^{-3}$ ,  $N_A = 0$ , is 2.0 cm long and has a cross sectional area  $0.2 \text{ cm}^2$ . A voltage is applied across the faces and a current of 400 mA flows. Calculate the electron and hole mobilities.

### ASSIGNMENT II – 2009

1. The circuit shown below is designed to generate current sinks  $I_o$ . If both transistors are identical:

- Derive function  $I_o$  in terms of  $I_{ref}$ .
- Transistor Q1 behaves as a diode. Why is a transistor used instead of a diode?
- What qualitative improvement will one achieve if FET transistors were used instead? Why?



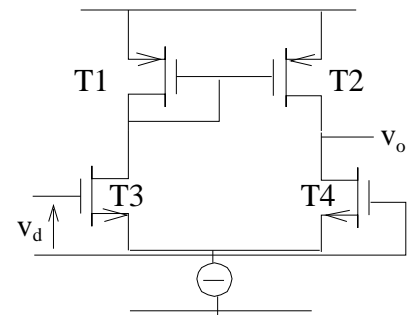
2. Consider the properties of a standard operational amplifier, say IC Operational Amplifier 741. Using simple circuit diagrams show how:

- Level shifting is used.
- Current sources are used.
- High input resistance is raised.

3. (a) Active loads are widely used in integrated circuit amplifiers. Why?  
 (b) A differential amplifier circuit shown below is used as an input circuit of a multistage amplifier. If the transconductances,  $r_o$  and the drain resistances,  $g_m$  are identical for all transistors, show that the differential gain  $A_d = g_m r_o / 2$

4. A simple output stage of an amplifier uses a single transistor emitter follower stage.

- What is the basic advantage of this configuration to the other types (i.e. CB, CE)?
- Calculate the power output efficiency of this amplifier.
- To get higher efficiencies what circuit arrangement can you use and why?



5. An ideal pn junction has  $N_D = 10^{18} \text{ cm}^{-3}$ ,  $N_A = 10^{16} \text{ cm}^{-3}$ ,  $\tau_p = \tau_n = 10^{-6} \text{ s}$  and a device area of  $1.2 \times 10^{-5} \text{ cm}^2$ . (a) Calculate the theoretical saturation current at 300 K, and (b) Calculate the forward and reverse currents at  $\pm 0.7 \text{ V}$ .

6. A varactor diode has a capacitance of 5 pF when the reverse bias voltage applied across it is 4 V. Determine the diode capacitance if the bias voltage is increased to 6 V.

7. An n-channel JFET has the following parameters:  $N_A = 10^{17} \text{ cm}^{-3}$ ,  $N_D = 10^{14} \text{ cm}^{-3}$ ,  $a = 1.0 \mu\text{m}$ ,  $L = 20 \mu\text{m}$ ,  $h = 100 \mu\text{m}$  and  $\mu_n = 1000 \text{ cm}^2/(\text{V}\cdot\text{s})$ . Calculate  $V_p$ ,  $V_{diff}$ ,  $G_0$ ,  $g_{m0}$  and  $g_{m(sat)}$  for this device. For  $g_{m0}$  use the values  $V_G = V_{p/2}$  and  $V_D = -V_{p/4}$ . For  $g_{m(sat)}$ , use the same value for  $V_G$ .

8. For an n-channel silicon JFET with  $N_A = 10^{19} \text{ cm}^{-3}$ ,  $N_D = 10^{16} \text{ cm}^{-3}$ ,  $a = 1.0 \mu\text{m}$ ,  $L = 20 \mu\text{m}$ ,  $Z = 100 \mu\text{m}$  and  $\mu_n = 1350 \text{ cm}^2/(\text{V}\cdot\text{s})$ , find the pinch-off voltage, the corresponding current at pinch off with  $V_G = 0$ , and the cut – off frequency. Take  $\epsilon = 16$  for Si.

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